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Aim

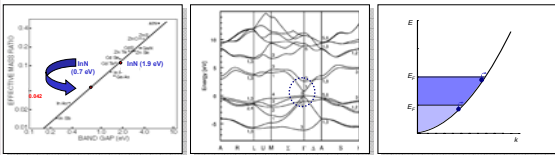
Experimental evidence for α -InN Γ -point effective electron mass value for polarization perpendicular to c-axis:

$$m_{\perp}^*(k=0) = 0.047 m_0$$

... increasing mass anisotropy towards lower Fermi energies, with approximately 17% smaller mass for polarization parallel to c-axis at $N = 1.8 \times 10^{17} \text{ cm}^{-3}$

Linear decrease of mobility in the double-Log(N) plot with better mobility parallel c-axis ($\mu_{\parallel} > \mu_{\perp}$) tentatively assigned to ionized impurity and boundary defect scattering

Motivation



Experimental and theoretical evidence for $E_g(\text{InN}) \sim 0.7 \text{ eV}$ — Γ -point effective mass has been overestimated!
 Anisotropic Γ -point effective mass predicted by empirical pseudopotential calculations
 Non-parabolic conduction band — effective mass depends on the free-charge-carrier concentration

B.R.Nag Phys. Stat. Sol. (b) 237, R1 (2003) D. Fritsch et al. PR B 69, 165204(2004); P. Carrier and S.-H. Wei JAP 97 (2005)

Γ -point effective mass and anisotropy not determined experimentally!

Far-infrared Magneto-optic Generalized Ellipsometry:

contactless, non-destructive determination of phonon and free-charge-carrier parameters (concentration, effective-mass, mobility) in thin layer samples by stratified dielectric model calculation:

Free-charge-carrier effects

$$\epsilon(\omega, H) = -(\epsilon_{\infty}^2) \left[(\omega^2 I + i\omega\gamma) - \begin{pmatrix} 0 & -h_x & h_y \\ h_x & 0 & -h_z \\ -h_y & h_z & 0 \end{pmatrix} \right]^{-1} \begin{pmatrix} \omega^2 \\ \omega^2 \\ \omega^2 \end{pmatrix}$$

$\langle \omega_c \rangle = q \left(\frac{H}{m_0} \right) m^{-1}$ Cyclotron (frequency) tensor
 $\langle \omega_p^2 \rangle = N \frac{e^2}{m_0} m^{-1}$ Plasma (frequency) tensor

Polar lattice contribution

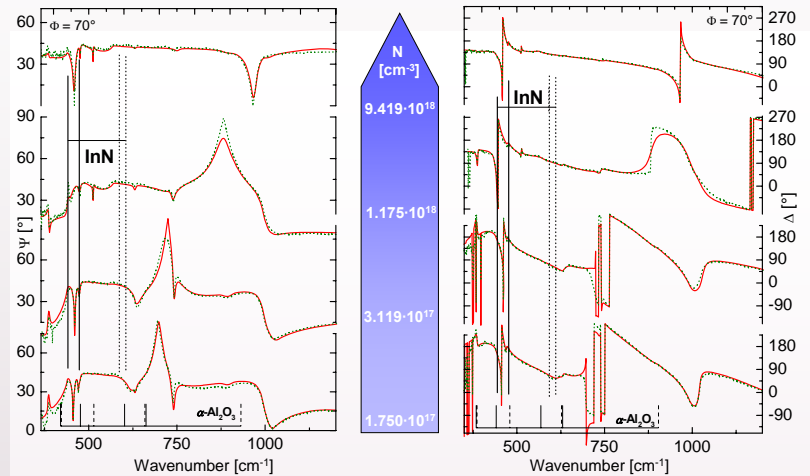
$$\epsilon_j(\omega) = \epsilon_{\infty, j} + \sum_{i=1}^l \frac{\omega_{LO, j}^2 + i\gamma_{LO, j}\omega - \omega_{TO, j}^2}{\omega^2 + i\gamma_{TO, j}\omega - \omega_{TO, j}^2}$$

Electronic contribution
 Infrared-active phonon modes

Recent publications on MO generalized ellipsometry:

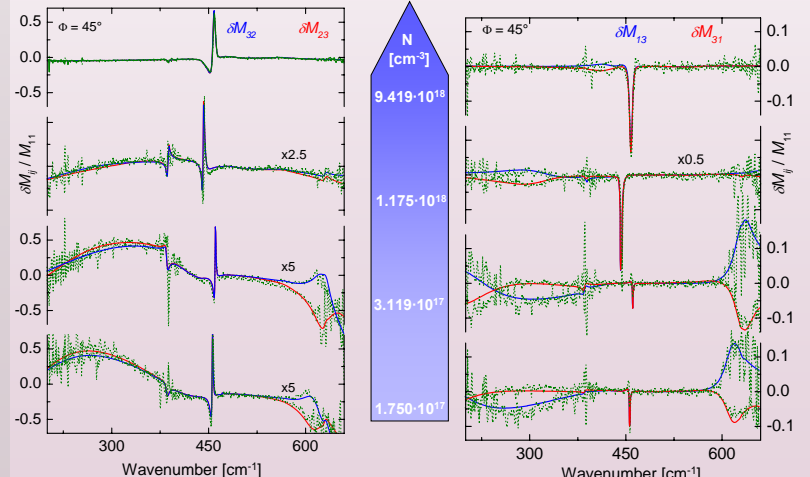
- T. Hofmann et al. Rev. Sci. Instrum. 77, 063902 (2006)
- M. Schubert et al. Thin Solid Films 455-456, 563-570 (2004)
- T. Hofmann et al. Mat. Res. Soc. Symp. Proc. 744, M5.32.1-6 (2003)
- T. Hofmann et al. Appl. Phys. Lett. 82, 3463-3465 (2003)
- M. Schubert et al. J. Opt. Soc. Am. A 20, 347-356 (2003)

Standard Ellipsometry (Zero-Magnetic-Field): Psi and Delta



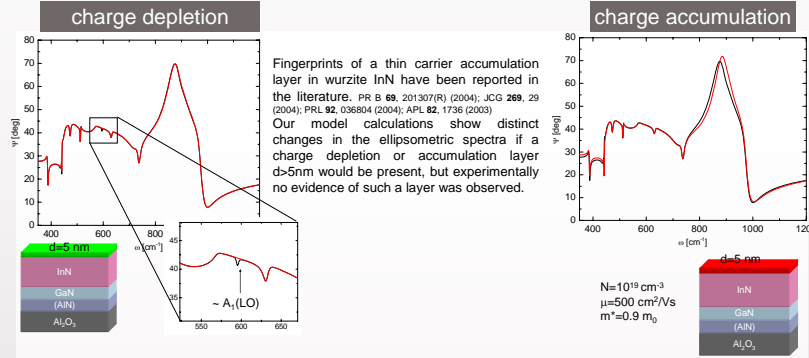
Zero-Field Standard Ellipsometry spectra reveal thickness, phonon mode frequency and broadening parameters, static dielectric constants, plasma frequency and plasma broadening parameters of InN and GaN layers upon model layer calculations

Magneto-optic Generalized Ellipsometry: Mueller Matrix



The spectra above are differences between Mueller matrix data (chiral elements M_{13} , M_{31} , M_{32} , and M_{23}) measured magnetic fields of +4.5T and -4.5T. The non-chiral elements M_{12} , M_{21} , M_{22} , and M_{33} vanish. Vertical solid and dashed lines within the Standard Ellipsometry spectra indicate the TO and LO mode frequencies, of the InN film and the sapphire substrate.

Results and Discussion



Anisotropy of α -InN Γ -point CB-electron mass and mobility

